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U.S. PATENT & TRADEMARK OFFICE  
JUN 08 2005

**TRANSMITTAL OF FORMAL DRAWINGS**

Docket No.  
**YOR920030194US1 (16695)**

In Re Application Of: **Cyril Cabral, Jr., et al.**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/643,534	August 19, 2003	Joannie A. Garcia	23389	2823	4259

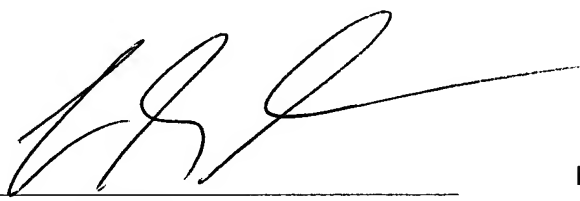
Invention: **ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS, GATES AND DIFFUSION BARRIERS**

Address to:  
**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

Transmitted herewith are:

4 sheets of formal drawing(s) for this application.

☒ Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

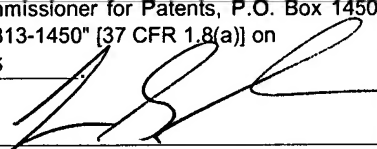


*Signature*

Dated: **June 6, 2005**

**Leslie S. Szivos  
Registration No. 39,394**

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<b>Leslie S. Szivos</b>	
<i>Typed or Printed Name of Person Mailing Correspondence</i>	